 Ш
Ш

Application/Control No.	Applicant(s)/Patent under Reexamination
10/060,315	EJIMA ET AL.
Examiner	Art Unit
Kelly L. Jerabek	2612

	SEARCHED			
Class	Subclass	Date	Examiner	
348	207.99	8/2/2005	KJ	
	208.99		-	
	208.111			
	333.01			
	333.06			
358	474			
	505	·		
382	291			
	293			
	· 296			
345	649			
	650	8/4/2005		

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
IEEE	8/2/2005	KJ
EAST Keyword		
Ngoc Yen Vu	1/12/2005	
Tuan Ho	8/3/2005	
John Villecco	8/3/2005	
·		